



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Steele et al.

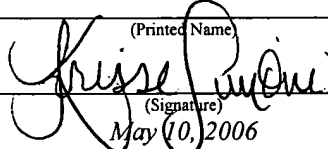
Title: WAFER INSPECTION SYSTEM

Appl. No.: 10/771,628

Filing Date: 02/03/2004

Examiner: Meagan S. Walling

Art Unit: 2863

CERTIFICATE OF MAILING	
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below.	
Krisse Simoni	
(Printed Name)	
	
(Signature)	
May 10, 2006	
(Date of Deposit)	

AMENDMENT AND REPLY UNDER 37 CFR 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated January 11, 2006, concerning the above-referenced patent application.

Applicant has enclosed with this amendment a Petition for Extension of Time to make this response timely.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 9 of this document.

Please amend the application as follows:

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